

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Trung T. Doan

Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING

Docket No.: 303.928US5

Serial No.: 09/652,713

Filed: August 31, 2000

Due Date: November 27, 2008

Examiner: Sylvia MacArthur

Group Art Unit: 1792

Customer No.: 73115

Confirmation No.: 4284

Notice of Allowance Date: August 27, 2008

Mail Stop Issue Fee

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following:

☒ Authorization to charge Deposit 19-0743 in the amount of \$1510.00 to cover the Large Entity Issue Fee Payment.

☒ Issue Fee Transmittal (Form PTOL-85).

☒ Communication Re: Fee Address (1 page).

Please charge any additional required fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG & WOESSNER, P.A. By

Customer No.: 73115

TBC:CMG:kerl


Timothy B. Clise

Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 24 day of November, 2008.

KATHLEEN E. ROTHROCK

Name


Kathleen E. Rothrock

Signature